

United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

APPLICATION NO		FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
09/527,534	27,534 03/16/2000		Koji Suzuki		2400	
23413	7590	09/07/2004		EXAMINER		
CANTOR		•	SEFER, AHMED N			
55 GRIFFI BLOOMFI				ART UNIT PAPER NUMBER		
	, <u> </u>			2826		
				DATE MAILED: 09/07/200-	1	

Please find below and/or attached an Office communication concerning this application or proceeding.

			/					
	Application No.	Applicant(s)						
	09/527,534 SUZUKI, KOJI							
Office Action Summary	Examiner	Art Unit						
	A. Sefer	2826						
The MAILING DATE of this communication Period for Reply	appears on the cover sheet	with the correspondence a	ddress					
A SHORTENED STATUTORY PERIOD FOR RE THE MAILING DATE OF THIS COMMUNICATIO - Extensions of time may be available under the provisions of 37 CF after SIX (6) MONTHS from the mailing date of this communication - If the period for reply specified above is less than thirty (30) days, a - If NO period for reply is specified above, the maximum statutory pe - Failure to reply within the set or extended period for reply will, by st Any reply received by the Office later than three months after the m earned patent term adjustment. See 37 CFR 1.704(b).	DN. R 1.136(a). In no event, however, may be reply within the statutory minimum of the string within the statutory minimum of the string will apply and will expire SIX (6) Medication to become	a reply be timely filed hirty (30) days will be considered time ONTHS from the mailing date of this of ABANDONED (35 U.S.C. § 133).						
Status								
1) Responsive to communication(s) filed on 0	<u> 6 April 2004</u> .							
2a) This action is FINAL . 2b) ⊠	This action is non-final.							
	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is							
closed in accordance with the practice und	er <i>Ex parte Quayle</i> , 1935 C	.D. 11, 453 O.G. 213.						
Disposition of Claims								
4)⊠ Claim(s) <u>10-12</u> is/are pending in the applic 4a) Of the above claim(s) is/are with 5)□ Claim(s) is/are allowed.								
6)⊠ Claim(s) <u>10-12</u> is/are rejected.								
7) Claim(s) is/are objected to.								
	☐ Claim(s) are subject to restriction and/or election requirement.							
Application Papers								
9) The specification is objected to by the Exan	niner.							
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.								
Applicant may not request that any objection to	the drawing(s) be held in abey	ance. See 37 CFR 1.85(a).						
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).								
11)☐ The oath or declaration is objected to by the	e Examiner. Note the attach	ed Office Action or form P	TO-152.					
Priority under 35 U.S.C. § 119								
 12) Acknowledgment is made of a claim for fore a) All b) Some * c) None of: 1. Certified copies of the priority document 	nents have been received.							
2. Certified copies of the priority docum								
3. Copies of the certified copies of the	, , ,	en received in this Nationa	l Stage					
application from the International Bu * See the attached detailed Office action for a		ot received.						
See the attached detailed entre action for a								
Attachment(s)								
 Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-948) 		w Summary (PTO-413) lo(s)/Mail Date						
Notice of Draftsperson's Patent Drawing Review (F10-940 Information Disclosure Statement(s) (PTO-1449 or PTO/SE Paper No(s)/Mail Date	′ <u> </u>	of Informal Patent Application (PT	O-152)					

U.S. Patent and Trademark Office PTOL-326 (Rev. 1-04) Application/Control Number: 09/527,534

Art Unit: 2826

DETAILED ACTION

Continued Examination Under 37 CFR 1.114

1. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on 4/6/04 has been entered.

Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 10-12 are rejected under 35 U.S.C. 103(a) as being unpatentable over Kunii et al US Patent No. 5,412,493 in view of Kawamura US Patent No. 5,858,807.

Kunii et al disclose (see figs. 1-4) a thin film transistor comprising semiconductor film or poly-silicon film (as in claim 12), a first gate insulating film 7 or silicon oxide film (as in claim 11), a second gate insulating film 8 and a gate electrode 9 formed on a surface of substrate 1, wherein said first gate insulating film covers said semiconductor film, and said second gate insulating film is made of a material or silicon nitride film (as in claim 11) for supplying hydrogen to said semiconductor film, but do not specifically disclose an insulating film with a smaller film thickness in a region not covered with a gate electrode than one covered with a gate electrode.

Application/Control Number: 09/527,534

Art Unit: 2826

Kawamura discloses (see fig. 1 and col. 3, lines 33-37) a silicon nitride insulating film 13 with a smaller film thickness in a region not covered with a gate electrode than a silicon nitride insulating film 8 in a region covered with said gate electrode formed on a silicon oxide insulating film (not shown) covering a semiconductor region.

Although applicant refers to the portion of the said insulating layer not covered with a gate electrode as gate oxide, it is nothing but a passivation layer which does not affect the channel region and through which contact regions can be formed as shown in fig. 3 of the invention. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to incorporate the teachings of Kawamura with Kunii et al's device, since that would minimize a degradation caused by hot carriers.

4. Claims 10-12 are rejected under 35 U.S.C. 103(a) as being unpatentable over Ogawa (JP 5-335578) in view of Kawamura US Patent No. 5,858,807.

Ogawa discloses in fig. 6 a thin film transistor comprising a semiconductor film or poly-silicon film (as in claim 12), a first gate insulating film 3 or silicon oxide film (as in claim 11), a second gate insulating film 4 and a gate electrode 5 formed on a surface of substrate 1, wherein said first gate insulating film covers said semiconductor film, and said second gate insulating film is made of a material or silicon nitride film (as in claim 11) for supplying hydrogen to said semiconductor film, but do not specifically disclose an insulating film with a smaller film thickness in a region not covered with a gate electrode than one covered with a gate electrode.

Kawamura discloses (see fig. 1 and col. 3, lines 33-37) a silicon nitride insulating film 13 with a smaller film thickness in a region not covered with a gate electrode than a

Application/Control Number: 09/527,534

Art Unit: 2826

silicon nitride insulating film 8 in a region covered with said gate electrode formed on a silicon oxide insulating film (not shown) covering a semiconductor region.

Although applicant refers to the portion of the said insulating layer not covered with a gate electrode as gate oxide, it is nothing but a passivation layer which does not affect the channel region and through which contact regions can be formed as shown in fig. 3 of the invention. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to incorporate the teachings of Kawamura with Ogawa's device, since that would minimize a degradation caused by hot carriers.

As for the said second gate insulating film being integrally formed over said first gate insulating film recited in claim 10, it carries no patentable weight In re Larson 144 USPQ 347 (CCPA 1965) (the term "integral" did not define over a multi-piece structure secured as a single unit. More importantly, the court went further and stated, "we are inclined to agree with the solicitor that the use of a one-piece construction instead of the [multi-piece] structure disclosed in Tuttle et al. would be merely a matter of obvious engineering choice" (bracketed material added). The court cited In re Fridolph for support.)

Any inquiry concerning this communication or earlier communications from the examiner should be directed to A. Sefer whose telephone number is (571) 272-1921.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nathan Flynn can be reached on (571) 272-1915.

Page 5

Application/Control Number: 09/527,534

Art Unit: 2826

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

ANS July 25, 2004

> Minhloan Tran Primary Examiner Art Unit 2826

couldn'tom